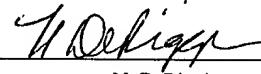




PATENT
Docket No. 204552021700

CERTIFICATE OF HAND DELIVERY

I hereby certify that this correspondence is being hand filed with the United States Patent and Trademark Office in Washington, D.C. on July 22, 2003.


N. DeRiggi

11/10
performed
10/1/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of:

Tetsuyoshi INOUE et al.

Serial No.: 09/987,010

Filing Date: November 13, 2001

For: SEMICONDUCTOR LASER
MANUFACTURING METHOD AND
SEMICONDUCTOR LASER

Examiner: Tuan N. Nguyen

Group Art Unit: 2828

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 27, 2003, please amend the above-identified patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 3 of this paper.

RECEIVED
JUL 25 2003
TECHNOLOGY CENTER 2800